

<b>Notice of References Cited</b>	Application/Control No. 09/747,779	Applicant(s)/Patent Under Reexamination KIM, HONG KOO	
	Examiner Marcos D. Pizarro-Crespo	Art Unit 2814	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,020,024	02-2000	Maiti et al.	427/248.1
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf et al., Silicon Processing for the VLSI Era Volume 1-Process Technology, 1986, Lattice Press, Sunset Beach, California, pp.56-57
	V	
	W	
	X	<i>Marcos D. Pizarro-Crespo</i> 5/12/2003

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.